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ATTY DOCKET NO.

03500.015809

APPLICATION NO.

09/955,137

APPLICANT

KAZUSHI NOMURA

FILING DATE

September 19, 2001

GROUP

2875

Date Submitted to PTO: [DATE]

U.S. PATENT DOCUMENTS AND PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
PM	2001/0006232 A1	7/01	Choi et al.	257	10	
PM	2002/0009637 A1	1/02	Murakami et al.	429	213	
PM	2002/0136896 A1	9/02	Takikawa et al.	428	408	
PM	4,728,851	3/88	Lambe	313	309	
PM	4,904,895	2/90	Tsukamoto et al.	313	336	
PM	4,956,578	8/99	Shimizu et al.	315	3	
PM	5,185,554	2/93	Nomura et al.	313	495	
PM	5,192,240	3/93	Komatsu	445	24	
PM	5,214,346	5/93	Komatsu	313	309	
PM	5,982,091	1/95	Maruo et al.	313	309	
PM	5,612,587	3/01	Itoh et al.	313	309	
PM	5,577,943	11/96	Vickers et al.	445	24	
PM	5,773,921	6/98	Keesmann et al.	313	309	
PM	5,935,639	8/99	Sullivan et al.	427	78	
PM	5,973,444	10/99	Xu et al.	313	309	
PM	5,982,091	11/99	Konishi	313	495	
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PM	6,448,709 B1	9/02	Chuang et al.	313	495	

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FOREIGN PATENT DOCUMENTS

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PM		0 394 698	10/90	EPO			
PM		0 443 865 A1	8/91	EPO			
PM		0 535 953 A2	4/93	EPO			
PM		0 614 209 A1	7/94	EPO			
PM		0 716 439 A1	6/96	EPO			
PM		0 758 028 A2	2/97	EPO			
PM		0 797 233 A2	9/97	EPO			
PM		0 871 195 A1	10/98	EPO			
PM		0 913 508 A2	5/99	EPO			
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PM		0 936 650 A1	8/99	EPO			
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PM		WO 89/07163	8/89	PCT			
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PM	2-112125	4/90	JAPAN			ABSTRACT
PM	3-20941	1/91	JAPAN			ABSTRACT
PM	3-295131	12/91	JAPAN			ABSTRACT
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PM	5-159696	6/93	JAPAN			ABSTRACT
PM	5-198253	8/93	JAPAN			ABSTRACT
PM	5-211029	8/93	JAPAN			ABSTRACT
PM	5-274997	10/93	JAPAN			ABSTRACT
PM	7-6714	10/95	JAPAN			NO
PM	8-115652	5/96	JAPAN			ABST./ ENG. TRANSLATION
PM	8-264109	10/96	JAPAN			ABSTRACT
PM	9-82214	3/97	JAPAN			ABSTRACT
PM	9-188600	7/97	JAPAN			ABSTRACT
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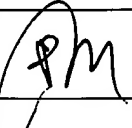
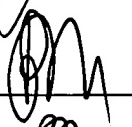

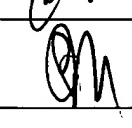
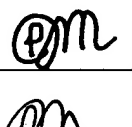
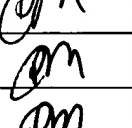
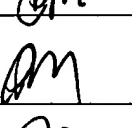
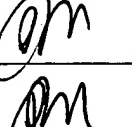
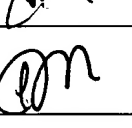
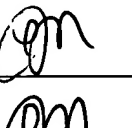
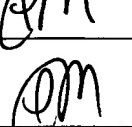
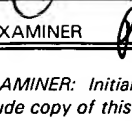




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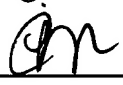



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FORM PTO 1449 (modified)		ATTY DOCKET NO. 03500.015809	APPLICATION NO. 09/955,137
U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		APPLICANT KAZUSHI NOMURA	
LIST OF REFERENCES CITED BY APPLICANT (Use several sheets if necessary)		FILING DATE September 19, 2001	
Date Submitted to PTO: [DATE]		GROUP 2875	
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